



FORM HDP-1449 (Based on Form PTO-1449) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Sheet 1 of 2	ATTORNEY DOCKET NO.	SERIAL NO.
	9319S-000579	10/719,998
	APPLICANT	
	Takashi Fujise	
	FILING DATE	GROUP
	November 21, 2003	2838

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No	
1.	↑	2000-236657	8/29/2000	Japan	—	X	
2.	↑	02-193566	7/31/1990	Japan	—	Abstract	X
3.	↑	2001-268894	9/28/2001	Japan	—	X	
4.	↑	2000-278937	10/6/2000	Japan	—	X	
5.	↑	2002-062858	2/28/2002	Japan	—	X	
6.	↑	2001-337653	12/7/2001	Japan	—	X	
7.	↑	2000-020147	1/21/2000	Japan	—	X	
8.	↑	2000-297107	10/24/2000	Japan	—	X	
9.	↑	2001-211635	8/3/2001	Japan	—	X	
10.	↓	2001-339939	12/7/2001	Japan	—	X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.		Communication from Japanese Patent Office re: counterpart application.

Examiner: <u>Stearrett</u>	Date Considered: <u>8/18/05</u>
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EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 2 of 2

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